

# All-inorganic QLEDs Based on Perovskite Emitters with High Humidity/water Stability

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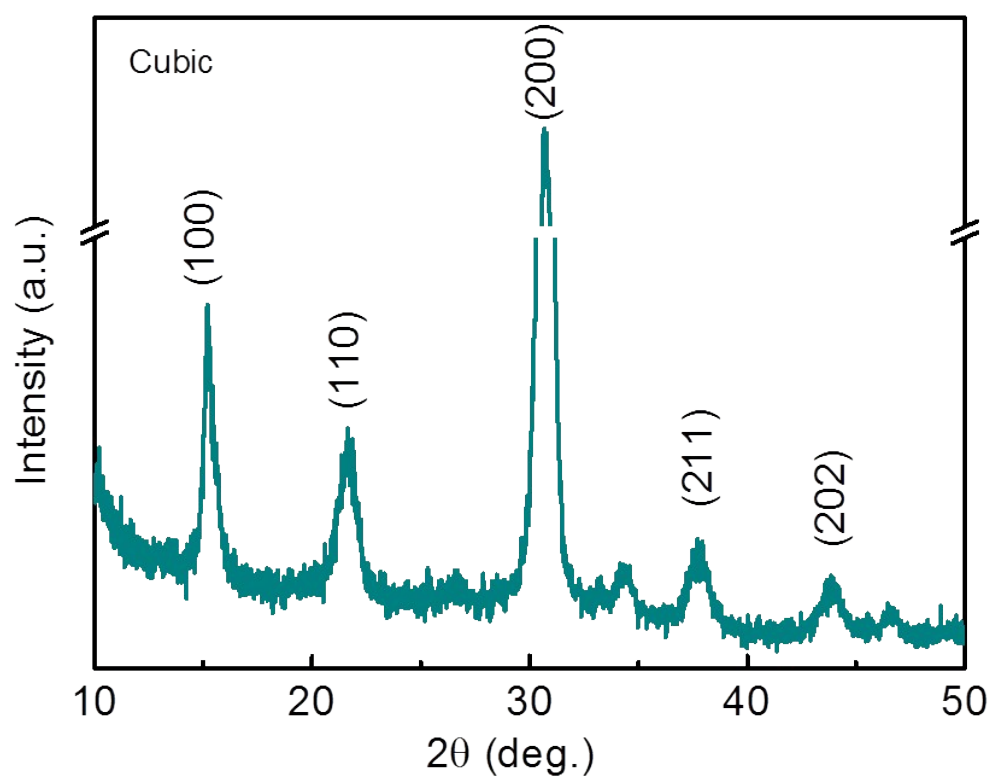
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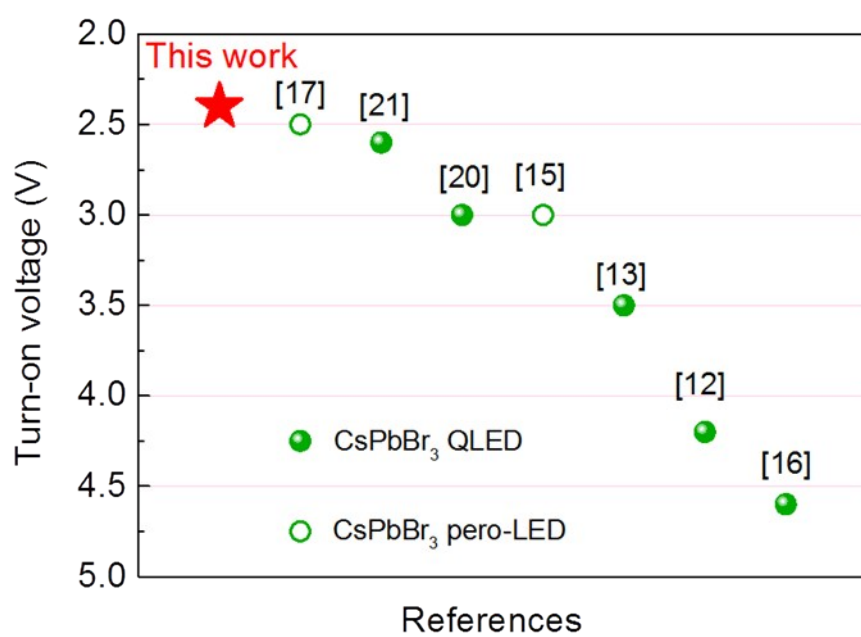
**KEYWORDS:** perovskites, CsPbBr<sub>3</sub> QDs, light-emitting diodes, all-inorganic, humidity stability

**Figure S1**



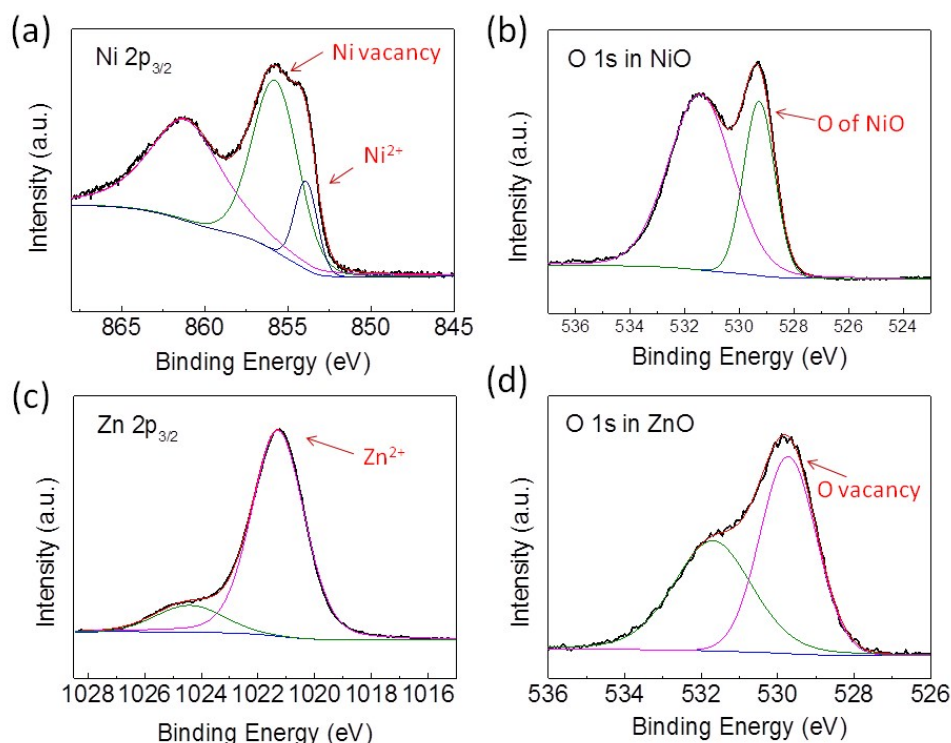
**Figure S1.** The XRD pattern of perovskite CsPbBr<sub>3</sub> QDs film.

**Figure S2**



**Figure S2.** Comparison of turn-on voltages of the reported CsPbBr<sub>3</sub> QLEDs including this work.

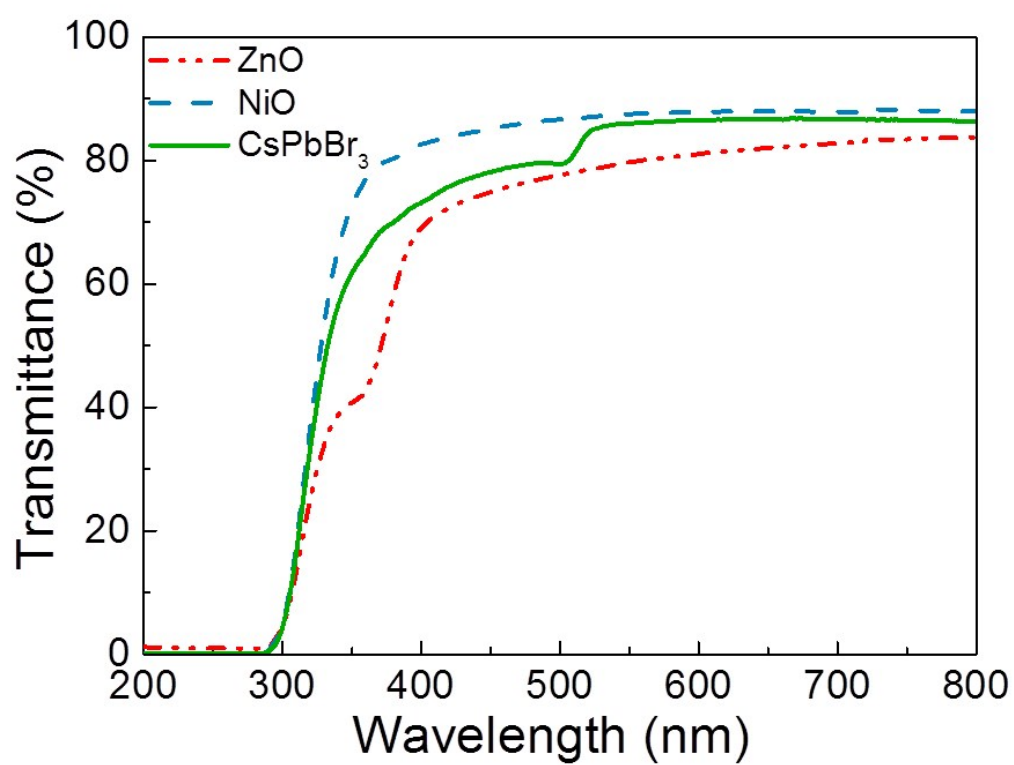
**Figure S3**



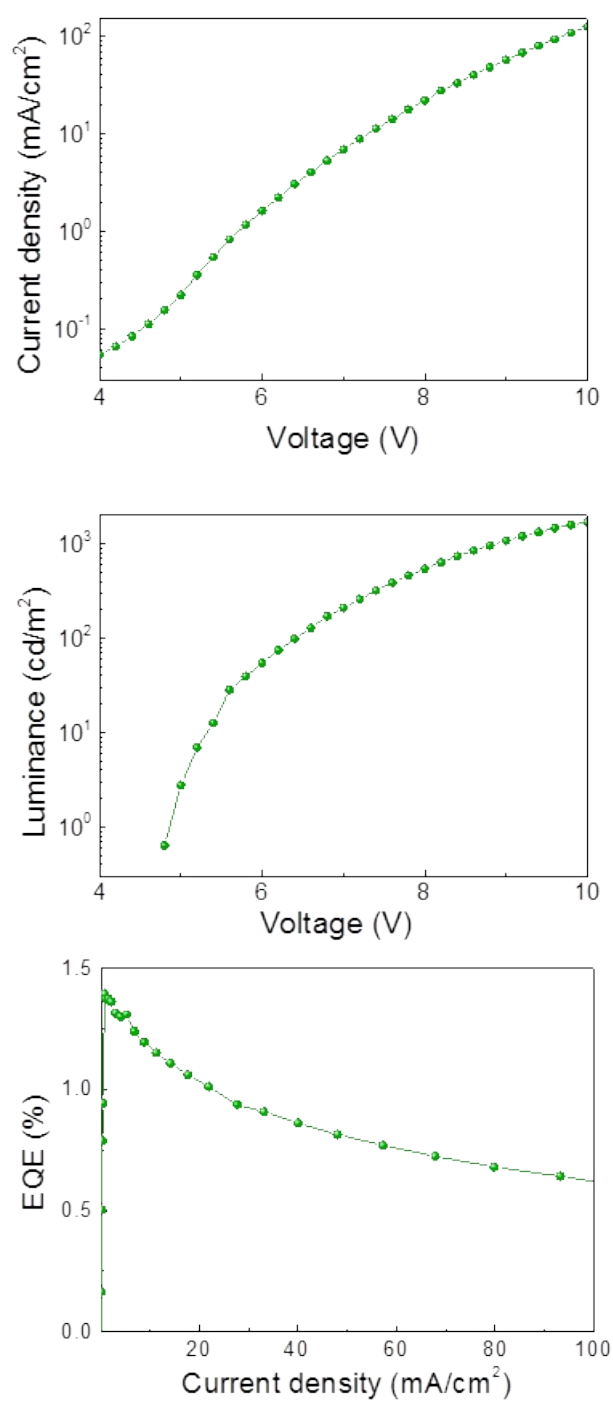
**Figure S3.** XPS spectra of the Ni 2p<sub>3/2</sub> peaks a) and O 1s peaks b) of the NiO films and Zn 2p<sub>3/2</sub> c) and O 1s d) of ZnO films.

Figure S3a presents Ni 2p<sub>3/2</sub> XPS spectra of the NiO<sub>x</sub> film, the peak centred at 853.9 eV belongs to Ni<sup>2+</sup> and the peak centred at 855.8 eV can be attributed to Ni<sup>3+</sup> which was induced by the interstitial oxygen defects or Ni vacancy. The broad peak located at 861.2 eV can be ascribed to a shake-up process in the NiO structure.<sup>1</sup> The O 1s XPS spectra of NiO<sub>x</sub> are shown in Figure S3b, the peak centred at 531.5 eV probably caused by nickel hydroxides and oxyhydroxides,<sup>2</sup> for the NiO film with defects will chemical adsorb water and form surface hydroxide during exposed to atmospheric conditions. The peak centred at 529.3 eV originates from the lattice O atoms of NiO. Figure S3c presents Zn 2p<sub>3/2</sub> XPS spectra of the ZnO film. The peak centred at 1021.2 eV pertains to Zn 2p<sub>3/2</sub>, while the shoulder peak located at 1024.4 eV may be related to interstitial Zn atoms<sup>3-4</sup>. The XPS spectra of O 1s peaks are shown in Figure S3d, the peak located at 529.7 eV was ascribed to Zn–O bonds in ZnO crystal. The peak centred at 531.7 eV is related to oxygen-deficient regions within the ZnO film.<sup>5</sup>

**Figure S4**



**Figure S4.** The optical transmittance spectra of CsPbBr<sub>3</sub> QDs, NiO and ZnO films.



**Figure S5.** The performance of QLEDs based on OCTLs

**Video S1** showing the all-inorganic QLEDs working under water over time (avi)

**Video S2** showing the QLEDs with organic CTLs working under water over time (avi)

## REFERENCES

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